

PATENT ASSIGNMENT COVER SHEET

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RECEIVING PARTY DATA	
Name:	National Institutes of Health (NIH), U.S. Dept. of Health and Human Services (DHHS), U.S. Government
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PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	13504480
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Date:	12/13/2013
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Invention Title: Optical-interface patterning by sub-surface laser engraving

Inventor(s): Tom Lewellen, William Hunter, Robert Miyaoka, Larry Macdonald

U.S. Filing/Issue Date: 4/26/2012

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Grant/Contract Number(s): EB002117

Foreign Applications filed/intended in (countries): European Patent Office, China

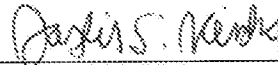
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Signed this 20th day of November, 20 13

By Jasbir (Jesse) Kindra
(Institutional Business Official)


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Title Director, IP Management

For UNIVERSITY OF WASHINGTON / Center for Commercialization
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